

UNITED STATES DEPARTMENT OF COMMERCE Patent and Trad mark Offic

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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR		ΓA	TTORNEY DOCKET NO.	
8/903,486	07/29/97	FORBES		L 300	3.326US1	
MM21/0415 SCHWEGMAN LUNDBERG WOESSNER & KLUTH			一	MINTEL, W	EXAMINER MINTEL, W	
O BOX 2938 INNEAPOLIS MN 55402				ART UNIT	PAPER NUMBER	
				2811	•	

DATE MAILED: 04/15/99

Please find below and/or attached an Office communication concerning this application or proceeding.

Commissioner of Patents and Trad marks





Application No.	Applicant(s)_		
DR/963486		Torbes	
Examiner (a 1 1 /	Group Art Unit	
Examiner Nilham N	11 n Tel	12/11	
on the cover sheet b		orrespondence a	ddress

Office Action Summary	78/963496 Forbes					
	Examiner Group Art Unit Wilham Mintel 28/1					
The MAILING DATE of this communication appears	on the cover sheet beneath the correspondence address—					
Peri d for Reply	7					
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO OF THIS COMMUNICATION.	EXPIREMONTH(S) FROM THE MAILING DATE					
 Extensions of time may be available under the provisions of 37 CFR 1.15 from the mailing date of this communication. If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, such period shall, by default, ex Failure to reply within the set or extended period for reply will, by statute. 	pire SIX (6) MONTHS from the mailing date of this communication .					
Status						
☐ Responsive to communication(s) filed on						
☐ This action is FINAL.						
 Since this application is in condition for allowance except fo accordance with the practice under Ex parte Quayle, 1935 (r formal matters, prosecution as to the merits is closed in C.D. 1 1; 453 O.G. 213.					
Disp sition of Claims						
Claim(s)	is/are pending in the application.					
16-21	is/are withdrawn from consideration.					
□ Claim(s)	is/are allowed.					
S Claim(s)	is/are allowed.					
□ Claim(s)	is/are objected to.					
☐ Claim(s)						
Application Papers	requirement.					
☐ See the attached Notice of Draftsperson's Patent Drawing F	Review, PTO-948.					
☐ The proposed drawing correction, filed on is ☐ approved ☐ disapproved.						
☐ The drawing(s) filed on is/are objected to by the Examiner.						
☐ The specification is objected to by the Examiner.						
☐ The oath or declaration is objected to by the Examiner.						
Pri rity under 35 U.S.C. § 119 (a)-(d)						
 □ Acknowledgment is made of a claim for foreign priority unde □ All □ Some* □ None of the CERTIFIED copies of the □ received. 	priority documents have been					
☐ received in Application No. (Series Code/Serial Number)						
☐ received in this national stage application from the Intern	, , , , , , , , , , , , , , , , , , ,					
*Certified copies not received:						
Attachment(s)	7+412					
Information Disclosure Statement(s), PTO-1449, Paper No(s						
☐ Notice of Reference(s) Cited, PTO-892	☐ Notice of Informal Patent Application, PTO-152					
☐ Notice of Draftsperson's Patent Drawing Review, PTO-948	□ Other					
Office Acti n Summary						

U. S. Patent and Trademark Office PTO-326 (Rev. 9-97)

Part of Paper No._

Application/Control Number: 08/903,486

Art Unit: 2811

1. The disclosure is objected to because of the following informalities: The specification contains Grammatik or other errors. Examples are below. To be fully responsive to this action, applicant must make a bona fide attempt to correct any other errors. Page 5, line 11, omits "a" before "gate".

Appropriate correction is required.

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless --

- 3. (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 4. Claims 1, 8 are rejected under 35 U.S.C. 102(b) as being anticipated by Oyama (367).
- 5. In re claim 1, line 1, the English abstract at line 1 recites a transistor. In re claim 1, line 2, the abstract at line 6 recites source and drain regions. In re claim 1, line 3, the abstract at lines 2-3 recites a silicon carbide gate electrode. In re claim 8, the abstract at line 4 recites an insulating layer.
- 6. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 7. Claims 2-7, 9-15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Oyama (367) in view of Halvis and Forbes (401).

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8. Oyama is described above but the English abstract lacks explicit mention of polycrstalline or microcrystalline SiC. Halvis at column 2, lines 20-30 teaches use of a poly SiC gate to make the formation of the underlying gate oxide easier. Forbes at column 2, lines 9-10, teaches micro SiC as a good conductor. Therefore, in re claims 2 and 3 it would have been obvious because of Halvis and Forbes, for the above reasons, to use poly or micro SiC as the gate of Oyama. In re claims 4-5, the English abstract does not specifically mention channel type except to recite an N type substrate 1, but it is well known to one of ordinary skill that MOSFET's exist as PMOSFET's or NMOSFET's. In re claim 6, the abstract, line 3, of Halvis teaches 50% carbon. In re claims 9-10, column 3, line 5, of Forbes teaches a 100A oxide insulating layer. Claims 11-14 are rejected as per the above claims. In re claim 15, Forbes at column 2, lines 1-32, teaches use of a SiC FET in a memory array context.

- 9. Cited of interest for a SiC floating gate 14 is Forbes (104). Cited for a floating gate 4 with bandgap larger than Si is Ichikawa (828). Cited for a poly Si gate is Yamazaki. Cited for a SiC insulation layer is Aoyama. The remaining references submitted by applicant are characterized by the Exmr. as merely of background interest.
- 10. Any inquiry concerning this communication or earlier communications from the examiner should be directed to W. Mintel whose telephone number is (703) 308-4916. The examiner can normally be reached on Monday-Thursday from 8:30AM to 5:00PM.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas, can be reached on (703) 308-2772. The fax phone number for the organization where this application or proceeding is assigned is (703) 308-7722.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Mintel/ds

04/12/99

William WINTE Primary Extri

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